Docket No.: 117755

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Morishige UCHIDA

Application No.: New U.S. Patent Application

Filed: November 14, 2003

SURFACE-TREATED ULTRAFINE METAL POWDER, METHOD FOR PRODUCING For: THE SAME, CONDUCTIVE METAL PASTE OF THE SAME, AND MULTILAYER CERAMIC CAPACITOR USING SAID PASTE

## **INFORMATION DISCLOSURE STATEMENT**

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the reference listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the reference be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- $\boxtimes$ This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.
- $\boxtimes$ An English-language Abstract of the non-English language reference 1 is attached hereto.
- $\boxtimes$ A computer-generated English translation of the following Japanese Patent Publication has been obtained from the website of the Japanese Patent Office ([http://www.jpo.go.jp]), and is attached, but has not been reviewed for accuracy. See Reference 1.

Respectfully submitted.

les A. Oliff Registration No. 27,07

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JAO:JSA/smk

Date: November 14, 2003

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DEPOSIT ACCOUNT USE **AUTHORIZATION** Please grant any extension necessary for entry; Charge any fee due to our Deposit Account No. 15-0461

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Form PTO-1449 (REV. 8-83)	8-83) PATENT & TRADEMARK OFFICE				ATTY DOCKET NO. 117755			APPLICATION NO. New U.S. Patent Application		
INFOR	tMATI	ION DISCLOSURE STATEMENT	l							
(Use several sheets if necessary)				APPLICANT Morishige UCHIDA						
			FILING DATE November 14, 2003							
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OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)										
EXAMINER DATE CONSIDERED										

Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in

conformance and not considered. Include copy of this form with next communication to applicant.

Date: November 14, 2003

Examiner: